



ELG Docket No. ILL01-010-US

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Named

Inventor: David Y. Kim

Serial No.: 10/760,144

Customer Service Center

Filing

Date: January 15, 2004

Initial Patent Examination Division

Title: PLATFORM AND SYSTEM FOR
CRYSTAL NUCLEATION AND
GROWTH

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant filed the above-identified application on January 15, 2004, but has not received a first Office Action. Please advise the undersigned when a first Office Action is expected to issue on this application.

Respectfully submitted,

Paul E. Rauch, Ph.D.,
Registration No. 38,591

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(312) 876-1400



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Examiner:

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Group Art Unit:

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**TRANSMITTAL
AND
CERTIFICATE OF MAILING UNDER 37 CFR 1.8**

I certify that the following correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

Commissioner for Patents
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Alexandria, VA 22313-1450

on

January 11, 2006
Date

Paul E. Rauch, Ph.D., Registration No. 38,591

typed or printed name of person signing Certificate

1. Status Inquiry

No Fee Due - - The Commissioner is authorized to charge any required fees **not covered by this credit card payment** or credit any overpayment to Deposit Account Number 50-3123. (A duplicate copy of this sheet is attached.)

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